

forming the passivation film consisting of chromium oxide by
5 applying heat treatment in an oxidizing atmosphere after coating
chromium on the metallic material of [which] the surface
roughness (Ra) of [a coat] metallic material surface is not more
than [1.5im] 1.5μm.

4. (Amended) [Parts contracting with fluid and a] A fluid
supplying/exhaust system for manufacturing semiconductors,
comprising metallic material having a chromium-oxide passivation
film according to claim 1.

IN THE ABSTRACT

Please delete the abstract on file and replace it with the
attached ABSTRACT OF THE DISCLOSURE.

If the Examiner has any questions or comments that would
speed prosecution of this case, he is invited to call the
undersigned at 219/485-6001.

Respectfully submitted,



Randall J. Knuth
Registration No. 34,644

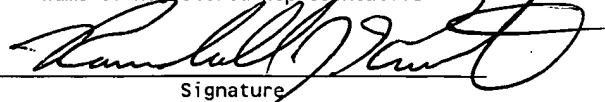
RJK/jrw
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ABSTRACT OF THE DISCLOSURE
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Name of Registered Representative



Signature

July 13, 2001

Date